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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/538,779	12/30/2005	In-Su Joo	PNK0217US	5493
23413 CANTOR COL	7590 02/11/200 LBURN, LLP	9		
20 Church Street 22nd Floor			WEISS, HOWARD	
Hartford, CT 06	5103		ART UNIT	PAPER NUMBER
			2814	
			NOTIFICATION DATE	DELIVERY MODE
			02/11/2009	ELECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

usptopatentmail@cantorcolburn.com

	Application No.	Applicant(s)		
	10/538,779	JOO ET AL.		
Office Action Summary	Examiner	Art Unit		
	HOWARD WEISS	2814		
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet with the	correspondence address		
A SHORTENED STATUTORY PERIOD FOR REP WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory perions after the reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the main earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION 1.136(a). In no event, however, may a reply be will apply and will expire SIX (6) MONTHS froute, cause the application to become ABANDON	DN. timely filed m the mailing date of this communication. IED (35 U.S.C. § 133).		
Status				
1) ☐ Responsive to communication(s) filed on <u>07</u> 2a) ☐ This action is FINAL . 2b) ☐ The solution of the solution	nis action is non-final. vance except for formal matters, p			
Disposition of Claims				
4) ☐ Claim(s) 1-6 is/are pending in the application 4a) Of the above claim(s) is/are withdi 5) ☐ Claim(s) 5 and 6 is/are allowed. 6) ☐ Claim(s) 1-4 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and Application Papers	rawn from consideration.			
9) The specification is objected to by the Examin	ner			
10) The drawing(s) filed on is/are: a) according to a deplicant may not request that any objection to the Replacement drawing sheet(s) including the correct of the oath or declaration is objected to by the left of th	ccepted or b) objected to by the se drawing(s) be held in abeyance. S ection is required if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.121(d).		
Priority under 35 U.S.C. § 119				
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 				
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summa Paper No(s)/Mail 5) Notice of Informal 6) Other:			

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Attorney's Docket Number: 6192.0590.US

Filing Date: 12/30/2005

Continuing Data: 371 of PCT/KR03/02708 (12/11/2003)

Claimed Foreign Priority Date: 12/11/2002 (KRX)

Applicant(s): Joo et al. (Choi)

Examiner: Howard Weiss

Pre-Appeal Brief Review

1. A pre-Appeal Brief conference was held on 12/16/2008. It was determined to withdraw the final rejection of 7/7/2008 and re-open prosecution. A new Office action follows:

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

3. Claims 1 and 2 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wei et al. (U.S. Patent No. 5,480,810), Yamazaki (U.S. Patent No. 6,239,470) and Sakaguchi et al. (U.S. Patent No. 6,453,008).

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Wei et al. show most aspects of the instant invention (e.g. Figures 1 and 2) including:

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- ➤ a gate wire formed on an insulating substrate 105 and comprising a gate electrode 122 and a gate line 125
- > a gate insulating layer **140** formed on said gate wire
- > a semiconductor layer 156 formed on said gate insulating layer
- ➤ a data wire formed on the gate insulating layer and including a data line 165, a source electrode 162 disposed on said semiconductor layer and a drain electrode 164 separated form said source electrode and disposed on said semiconductor layer
- ➤ a photodiode 130 including first 124 and second 138 electrodes with a photo-conductive layer disposed therebetween, said photo-conductive layer comprising N-I-P amorphous, semiconductove layers 132,134,136, respectively
- ➤ a passivation layer 140 on the photodiode and having a contact hole 148 exposing said second electrode
- > a bias signal line 166 connected to said second electrode via said contact hole

Wei et al. does not show the passivation layer on the semiconductor layer, the data wire and drain electrode and a light blocking layer covering the photodiode and disposed directly on said passivation layer and the bias signal line. Yamazaki teaches (e.g. Figures 4 and 5) to have a passivation layer 213 on a semiconductor layer 210, the data wire 216 and drain electrode 209 and a light blocking layer 214 directly on said passivation layer and the bias signal line (not shown) to archive high performance (Column 1 Lines 42 and 46). It would have been obvious to a person of ordinary skill in the art at the time of invention to have a passivation layer on a semiconductor layer, the data wire and drain electrode and a light blocking layer directly on said passivation layer and the bias signal line as taught by Yamazaki in the device of Wei et al. to archive high performance.

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Sakaguchi et al. teach (e.g. Figure 3) to form a light blocking layer covering photodiodes **1A** to provide a means to reduce nose due to dark current (Column 4 Lines 63 to 67). It would have been obvious to a person of ordinary skill in the art at the time of invention to form a light blocking layer covering photodiodes as taught by Sakaguchi et al. in the device of Wei et al. to provide a means to reduce nose due to dark current.

Allowable Subject Matter

4. Claims 5 and 6 are allowed.

5. The following is a statement of reasons for the indication of allowable subject matter: a thin film transistor array panel as claimed including a disconnected region disposed between the source and drain electrode could not be anticipated nor, in combination, be rendered obvious over the prior art of record.

Response to Arguments

6. Applicant's arguments with respect to Claims 1 to 4 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

- 7. Papers related to this application may be submitted directly to Art Unit 2814 by facsimile transmission. The faxing of such papers must conform with the notice published in the Official Gazette, 1096 OG 30 (15 November 1989). The Art Unit 2814 Fax Center number is (571) 273-8300. The Art Unit 2814 Fax Center is to be used only for papers related to Art Unit 2814 applications.
- 8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Howard Weiss at (571) 272-1720 and between the hours of 7:00 AM to 3:00 PM (Eastern Standard Time) Monday through Friday or by

e-mail via <a href="mailto:https://example.com/https://example.com

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- 9. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).
- 10. The following list is the Examiner's field of search for the present Office Action:

Field of Search	Date
U.S. Class / Subclass(es): 257/ 59, E27.14	thru 2/3/2009
Other Documentation: none	
Electronic Database(s): EAST	thru 2/3/2009

HW/hw 9 February 2009 /Howard Weiss/ Primary Examiner Art Unit 2814